



**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 2823**

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.2622

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Gaku MINAMIHABA, et al. ) Group Art Unit: 2823  
Serial No.: 09/932,943 ) Examiner: Lee, Hsien Ming  
Filed: August 21, 2001 )  
For: SLURRY FOR CHEMICAL )  
MECHANICAL POLISHING AND )  
METHOD OF MANUFACTURING )  
SEMICONDUCTOR DEVICE )

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR RECONSIDERATION AFTER FINAL**

In reply to the Final Office Action mailed September 16, 2004, with a period for response extending through February 16, 2005 by the attached Petition for Extension of Time of Two Months and requisite fee payment, Applicants request the Examiner's reconsideration in view of the remarks that follow:

**Remarks** begin on page 2 of this paper.